Notice of References Cited Application/Control No. 10/649,738 Applicant(s)/Patent Under Reexamination CHOI ET AL. Examiner Mike Qi Art Unit Page 1 of 1

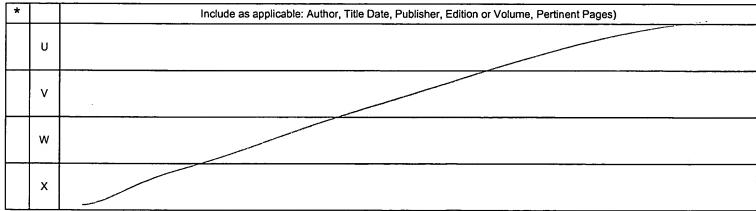
U.S. PATENT DOCUMENTS

*	-	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification .
	Α	US-5,514,426	05-1996	Eguchi, Ken	428/1.4
	В	US-5,618,592	04-1997	Nagae et al	428/1
	С	US-6,545,738 B2	04-2003	Son et al	349/172
	D	US-4,639,089	01-1987	Okada et al	350/341
	Ε	US-4,879,059	11-1989	Hanyu et al	252/299.4
	F	US-5,504,600	04-1996	Pirs et al	359/51
	G	US-6,108,061	08-2000	Sako et al	349/85
-	Н	US-2002/0191137 A1	12-2002	Kondoh	349/123
	1	US-6,429,914 B1	08-2002	Kubota et al	349/86
	J	US-2003/0011732 A1	01-2003	Ishihara et al	349/117
	К	US-5,973,762	10-1999	Vorfloussev	349133
	L	US-6,151,090	11-2000	Tanaka etal	349/134
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification			
	N								
	0								
	Р								
	Q								
	R								
	s								
	Т								

NON-PATENT DOCUMENTS



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